Development of comprehensive temperature-dependent plasma-chemical kinetic reaction mechanisms for plasma systems at elevated temperatures (300–1200 K)

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Abstract: Non-thermal plasma discharges could play an important role in supporting and/or electrifying traditional thermal processes. To scientifically advance applications in this area, plasma-chemical kinetic studies must describe both electron-induced and thermally-induced reactions. Here we present our effort to establish a combined experimental and modelling platform, and the development of a temperature-dependent H_2/O_2 plasma-chemical reaction mechanism as building block to study any temperature-dependent plasma-assisted process.

Keywords: H₂, O₂, HO₂, plasma-chemical kinetics, temperature-controlled DBD.

1.Introduction

Plasma processes have the potential to become a key technology for transforming electrical energy into chemical energy by synthesizing chemicals and fuels of interest. Additionally, as the production of energy is shifting to renewable sources, a similar shift towards electrification in industrial processes is on the horizon.[1]

While one of the main strengths of plasmas is initiating reactions through electron collisions leading to the production of radicals, the selective recombination of these radicals to desired products remains challenging. Recently, we revealed that although electron-induced reactions initiate chemical reactions regardless of temperature, the thermally induced reactions have a dominant effect on the selectivity and final product composition.[1-4]

A promising route to affect the process selectivity is the combination of plasma with a catalyst. This approach can increase selectivity and yield, and decrease the temperature requirements. The plasma-catalyst interaction highly depends on the process, the plasma properties and the type of catalyst. The catalyst can be activated by a combination of heat and the plasma generated reactive species.[5]

As a result plasma technology provides unique posibilites by providing two independent ways to control chemical reactions: electron-induced and thermally induced chemistry. This also highligths the need to explore the effect of the gas temperature on processes of interest for non-thermal plasma discharges.

To date, most work has focused either on the development of room temperature plasma-chemical reaction mechanisms or temperature-dependent plasma-chemical reaction mechanisms under highly diluted conditions. However, due to the differences in system reactivity, extending these studies to realistic conditions (e.g., practically diluted atmospheric or higher pressures) is not without complications.[6-7]

Therefore, we developed a combined experimental and modelling approach, and compiled a temperaturedependent plasma-chemical reaction mechanism for gas temperatures below 1200 K to study any temperaturedependent plasma-assisted process (oxidation, reduction, combustion, reforming, synthesis, catalysis). Here we introduce our modelling approach and present the results for the first step, a H_2/O_2 plasma-chemical reaction mechanism which serves as a building block for both carbon (CO₂,[8] CH₄, higher hydrocarbons, alcohols) and nitrogen (N₂, NO_x, NH₃ [9-10]) containing systems.

Interestingly, even for a simple H_2/O_2 mixture, a nonlineair temperature-dependent trend in the form of Negative Temperature Coefficient (NTC)-like behavior was experimentally observed in a temperature range of 575–775 K. Based on numerical analyses, this NTC behavior could be attributed to a combination of the electron-induced and thermally induced chemistry.

2. Description of the model

2.1. KAUSTKin

We developed a zero-dimensional (0D) plasma-chemical kinetic model, KAUSTKin.[11] The model couples ZDPlasKin [12] and Chemkin [13] to solve the time-dependent species and energy equations. The rates of electron impact reactions are calculated in ZDPlasKin using the Boltzmann equation solver (BOLSIG+ [14]) based on the supplied cross-section data and the corresponding electron energy distribution function (EEDF). The rates of the conventional (thermal) reactions, on the other hand, are calculated by the Chemkin library. A schematic representation of the model is given in **Figure 1**, more details about KAUSTKin can be found in [11].



Fig. 1. Schematic of the modules and data flow of the plasma-chemical kinetic model, KAUSTKin. Reproduced from ref [11] with kind permission; published by Elsevier.

2.2. Temperature-dependent reaction mechanism The reaction mechanism shown here consists of three parts: a plasma H_2/O_2 mechanism for the electron-induced chemistry, a conventional (thermal) H_2/O_2 mechanism, and an ozone (O₃) mechanism.

The plasma H_2/O_2 mechanism was compiled from litereature consisting of 265 reactions with electrons, ions, and excited species, and relied on the Biagi database [15] for electron impact cross section data.

For the conventional thermal H_2/O_2 mechanism we started from NUIGMech1.1 (35 reversible reactions),[16-17] and modified it by (i) replacing the rate data for H + $HO_2 \rightarrow H_2 + O_2$ with the data from Konnov,[18-19] (ii) replacing the rate data for H + O_2 (+M) $\rightarrow HO_2 + M$,[20] and (iii) adding eight reversible O_3 reactions.[11] As a result, the full mechanism considered 21 species (**Table 1**) and 351 reactions: 155 electron impact reactions, 14 ion reactions, 112 reactions with excited states, and 70 neutral reactions.

The plasma mechanism omitted several electronic and vibrational excited states and parts of the ion-ion chemistry, maintaining minimal electron-ion reactions (see [11]). This approach greatly reduced the complexity of the mechanism and analysis, so that the mechanism can be further optimized for multi-dimensional simulations in the future.

Table 1. Species included in the temperature-dependent H_2/O_2 plasma-chemical reaction mechanism.

	Neutral	Excited	Charged
electrons			e
O containing	$\begin{array}{c} O_3 \\ O_2 \\ O \end{array}$	$O_2(a^1), O_2(b^1), O_2(c) \\ O(^1D), O(^1S)$	$\begin{array}{c} O_2^+ \\ O^+ \end{array}$
H containing	$\begin{array}{c} H_2\\ H\end{array}$		$\begin{array}{c} H_2{}^+ \\ H^+ \end{array}$
O-H containing	OH HO ₂ H ₂ O H ₂ O ₂	OH(V)	$\rm H_2O^+$

3. Description of the experiments

The experimental apparatus consisted of a temperaturecontrolled dielectric barrier discharge (DBD) reactor, a power supply system, a reactant supply system, and an analysis system. The temperature-controlled DBD reactor was composed of an electric furnace containing a coaxial DBD reactor consisting of a quartz tube with an inner diameter of 20-mm, and a stainless-steel rod with a diameter of 18-mm serving as high voltage electrode, resulting in a 1-mm discharge gap. A 40-mm wide stainless-steel mesh was wrapped around the outside of the quartz tube to serve as a ground electrode (Figure 2). H₂ (Parker, 40H, hydrogen generator, 99.99995 %) and O₂ (99.995 %) were used as feed gases with a constant total flow rate of 200 sccm. The reactor was supplied by an adjustable high voltage AC power supply (Trek), which could supply voltage and current up to 20 kV. The discharge power (P_{dis}) was varied between 1.25–20 W, providing a specific energy input for all investigated cases of 0.375–6 J/cm³. The gas temperature (T_g) was varied between 300–900 K. The analysis system consisted of an inline gas chromatograph (GC) with two calibrated Thermal Conductivity Detectors (TCD), which were used to analyze the conversion of O₂ and H₂ as a measure for the oxidation of H₂. More details about the experimental setup can be found in [11].



Fig. 2. Schematic of the experimental setup. Reproduced from ref [11] with kind permission; published by Elsevier.

4. Results and discussion

To validate the temperature-dependent plasma-chemical H_2/O_2 reaction mechanism, the oxidation of H_2 was studied for three different mixtures: extremely lean ($\phi = 0.01$, **Figure 3a**), extremely rich ($\phi = 49.5$, **Figure 3b**), and stoichiometric ($\phi = 1$, **Figure 3c**). This approach allowed to separately evaluate the effects of the O₂ chemistry, the H_2 chemistry, and its combination, respectively.

For all mixtures non-lineair NTC-like oxidation behaviour was observed in a temperature range of 575 \leq Tg \leq 775 K. This behavior could be attributed to a combination of physical and chemical effects: (i) the dominant contribution originated from non-lineair changes to the reduced electric field (E/N) as T_g was varied in the DBD reactor, which affected the degree of energy transferred to the electron-impact dissociation processes; and (ii) the OH production was influenced by the temperature-dependent kinetics related with H and HO₂, showing similar behaviour compared to conventional NTC-kinetics with saturated hydrocarbons. Based on chemical and sensitivity analyses HO₂ was found to be the most important intermediate species governing the overall oxidation process, however, the key reactions responsible for the NTC behavior varied for the different mixtures.

4.1. Extremely lean ($\phi = 0.01$)

For the extremely lean case (98 vol% O_2 and 2 vol% H_2 , **Figure 3a**) the oxidation process is initiated by the electron impact dissociation of O_2 to form O and $O(^1D)$ radicals, whereas the electron impact dissociation of H_2 is insignificant. This is in stark contrasts with the result of highly diluted mixtures, where excited metastable states of the diluent (such as Ar or He) dominate the dissociation of O_2 and H_2 through dissociative quenching reactions [7].



Fig. 3. Experimental (symbols) and numerical (solid lines) results for the plasma-assisted oxidation of H₂/conversion of O₂ as a function of T_g for the H₂/O₂ mixture ($\phi = (a) 0.01$, (b) 49.5, and (c) 1.0) at various P_{dis} . The grey shaded area indicates the experimentally found NTC-like regime.

At $T_g < 575 \text{ K O}(^1\text{D})$ was mainly responsible for the seed of H radicals (O(^1D) + H₂ \rightarrow OH + H (R1)), which are required to produce the key intermediate, HO₂. The HO₂ pathway transformed H radicals into OH radicals via H + O₂ (+M) \rightarrow HO₂ (+M) (R2) and HO₂ + O \rightarrow OH + O₂ (R3).

However, at this T_g , O_3 production suppresses the oxidation reactions R1 and R3 by consuming the available O radicals (O + O₂ (+M) \rightarrow O₃ (+M) (R4)) and OH radicals (O₃ + OH \rightarrow O₂ + HO₂ (R5)).

At $575 \le T_g \le 700$ K, a transition of reactions occurs: (i) a gradual shift in the main branching and propagation reactions producing OH towards $H_2 + O \rightarrow OH + H$ (R6), (ii) a high HO₂ production in combination with the chain termination reaction, HO₂ + HO₂ \rightarrow H₂O₂ + O₂ (R7), leads to a deterioreated OH production rate, resulting in NTC-like behavior.

At $T_g \ge 700$ K, consumption of HO₂ occurs via H + HO₂ \rightarrow OH + OH (R8), which together with increased rates of the chain branching reactions H₂ + O \rightarrow OH + H (R9) and especially O₂ + H \rightarrow O + OH (R10) leads to the recovery of the OH production and hence oxidation process.

Interestingly, the excited states of O-species (mainly transferring energy through collisional quenching) played a minor role in the overall oxidation process.

4.2. Extremely rich ($\phi = 49.5$)

For the extremely rich case (1 vol% O_2 and 99 vol% H_2 , **Figure 3b**) the oxidation process is initiated by the electron impact dissociation of H_2 , to form H radicals, whereas the electron impact dissociation of O_2 is negligible. To obtain similar oxidation P_{dis} was lowered by a factor of four, due to the enriched chain branching reactions and the absence of oxidation limiting O_3 production in the rich mixture.

Again, HO₂ was the key species controlling the oxidation process through the transformation of H radicals into OH radicals via R2 and R8, eventually leading to full oxidation through H₂ + OH \rightarrow H₂O + H (R11).

At $T_{\rm g} < 575$ K, H₂O₂ production slightly suppressed the oxidation by consuming both HO₂ radicals via R7 and OH radicals via H₂O₂ + OH \rightarrow H₂O + HO₂ (R12).

At $575 \le T_g \le 700$ K, a significant increase in the chain termination reaction H + HO₂ \rightarrow H₂ + O₂ (R13) led to: (i) a gradual decrease in the production of HO₂ via R2, and (ii) gradual decrease in the production of OH via R8, due to the competition for the available H and HO₂ radicals, which again leads to a deterioreated OH production rate, resulting in NTC-like behavior.

At $T_{g} \ge 700$ K, increased rates of the chain branching reactions R9 and especially R10 leads to the recovery of the OH production and hence oxidation process.

4.3. Stoichiometric ($\phi = 1$)

For the stoichiometric case (33.3 vol% O_2 and 66.7 vol% H_2 , **Figure 3c**) the oxidation process is initiated by a combination of the electron impact dissociation of H_2 and O_2 , leading to the production of H, O and $O(^1D)$ radicals.

HO₂ remained the key species controlling the oxidation process through the transformation of H radicals into OH radicals via R2 and R8, followed by full oxidation through R11. From the chemical and sensitivity analyses it became clear that the observed oxidation behaviour for the stoichiometric case, is governed by a combination of the mechanisms observed for both the lean and rich cases. Additionally, the high H radical and O_2 concentration leads to a significant production of HO₂ (R2) and H₂O₂ (R7).

Based on the high uncertainty and the high sensitivity of the oxidation process to reactions R2, R8, and R13, these are considered as key reactions to further optimizations of the H_2/O_2 reaction mechanisms.

5. Conclusions

We developed a combined experimental and modelling platform, and compiled a temperature-dependent H_2/O_2 plasma-chemical reaction mechanism for gas temperatures below 1200 K as building block to study any temperature-dependent plasma-assisted process (oxidation, reduction, combustion, reforming, synthesis, catalysis).

For the first time non-lineair temperature-dependent oxidation behavior in the form of a NTC-like trend was observed for a H_2/O_2 mixture in a temperature range of 575–775 K. Through a numerical analysis this could be attributed to a combination of the electron-induced and thermally induced chemistry. As such, our findings emphasized the significance of both plasma-physical characteristics and plasma-chemical kinetics on temperature-dependent plasma-assisted processes.

Future efforts should continue in this direction, focusing on rigorous, fundamental investigations into temperaturedependent plasma-chemical kinetics, with as final goal to design and develop plasma systems for any target process. Special attention in this area should be given to the production of carbon-free fuels such as H_2 and NH_3 , and the production of feedstock (petro)chemicals.

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7. References

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